


6-903

2813

<b>TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT</b> (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. 08228/020001
In Re Application Of: <b>Shiro SAKAI</b>			
Serial No. 10/056,611	Filing Date 01/24/2002	Examiner Thanh T. Nguyen	Group Art Unit 2813
Title: <b>METHOD FOR MANUFACTURING GALLIUM NITRIDE COMPOUND SEMICONDUCTOR ELEMENT</b>			
<div style="display: flex; justify-content: space-between; align-items: flex-start;"><div style="width: 20%;"></div><div style="width: 60%; text-align: center;"><p>Address to: <b>Assistant Commissioner for Patents Washington, D.C. 20231</b></p><p><b>37 CFR 1.97(b)</b></p><p>1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application; within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or before the mailing date of a first Office Action on the merits, whichever event occurs last.</p><p style="text-align: center;"><b>37 CFR 1.97(c)</b></p><p>2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after three months of the filing of a national application, or the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or after the mailing date of a first Office Action on the merits, whichever occurred last but before the mailing date of either:</p><div style="margin-left: 40px;"><p>1. a Final Action under 37 CFR 1.113, or</p><p>2. a Notice of Allowance under 37 CFR 1.311,</p></div><p style="margin-left: 40px;">whichever occurs first.</p><p>Also submitted herewith is:</p><div style="margin-left: 40px;"><p><input type="checkbox"/> a certification as specified in 37 CFR 1.97(e);</p><p style="text-align: center;"><b>OR</b></p><p><input type="checkbox"/> the fee set forth in 37 CFR 1.17(p) for submission of an Information Disclosure Statement under 37 CFR 1.97(c).</p></div></div><div style="width: 20%; text-align: center; font-size: small;"><p>RECEIVED JUN 11 2003 TO 2000 HALL</p></div></div>			

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**  
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.  
08228/020001

In Re Application Of: **Shiro SAKAI**

Serial No.  
10/056,611

Filing Date  
01/24/2002

Examiner  
Thanh T. Nguyen

Group Art Unit  
2813

Title: **METHOD FOR MANUFACTURING GALLIUM NITRIDE COMPOUND SEMICONDUCTOR ELEMENT**



**Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

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- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. **50-0591** as described below. A duplicate copy of this sheet is enclosed.
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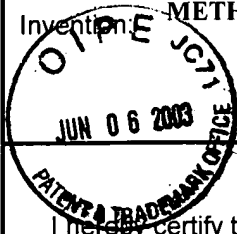
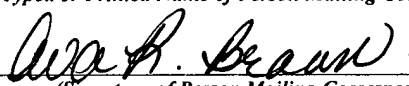
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*Jeffrey S. Bergman* 45,925  
\_\_\_\_\_  
Signature

Dated: *6/6/03*

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CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)			Docket No.
Applicant(s) Shiro SAKAI			08228/020001
Serial No. 10/056,611	Filing Date 01/24/2002	Examiner Thanh T. Nguyen	Group Art Unit 2813
Invention: METHOD FOR MANUFACTURING GALLIUM NITRIDE COMPOUND SEMICONDUCTOR ELEMENT			
<div><div></div><div>I hereby certify that the following correspondence:</div><div><div>Information Disclosure Statement</div><div>(Identify type of correspondence)</div></div></div>			
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